

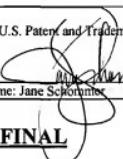
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: MURAKAMI, ET AL. Examiner: HA, NGUYEN T
Serial No.: 10/565716 Group Art Unit: 2831
Filed: January 25, 2006 Docket No.: 20162.0012USWO
Title: METHOD FOR FORMING OXIDE FILM ON METAL SURFACE USING
IONIC LIQUID, ELECTROLYTIC CAPACITOR AND ELECTROLYTE
THEREOF

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CERTIFICATE OF TRANSMISSION

I hereby certify that this paper is being transmitted by EFS Web to the U.S. Patent and Trademark Office on October 8, 2010.

By: 
Name: Jane Schommer

AMENDMENT AFTER FINAL

Mail Stop: AF
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Commissioner:

In response to the Office Action mailed July 8, 2010, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks begin on page 5 of this paper.